

SYSTEM AND METHOD FOR INTERLOCKING MANAGEMENT IN SEMICONDUCTOR MATERIAL SUPPLY EQUIPMENT

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ABSTRACT OF THE INVENTION

10 In the present invention, a system for interlocking material
supply equipment in semiconductor manufacture management system
comprises collecting means for collecting a user's identification and
content identification of material supply equipment. Communication
means is for transferring the user's identification and the content
15 identification. A controller is communicated with the material supply
equipment and the collecting means through the communication means.
Alarm means is coupled to the material supply equipment and
communicated with the controller. A method for interlocking managing
change materials of material supply equipment comprises collecting a
20 changed material information in an material supply equipment. The
changed material information is checked by a controller communicated
with the material supply equipment. An alarm message is transferred
to the material supply equipment from the controller. The
corresponding material supply equipment is disabled according to said
alarm message.